	Application No.	Applicant(s)
N-4: of Allowahility	10/695,381	GOLOVCHENKO ET AL.
Notice of Allowability	Examiner	Art Unit
	Rodney G. McDonald	1753
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not included will be mailed in due course. THIS
1. \boxtimes This communication is responsive to <u>Request for Continuin</u>	ng Examination filed 3-6-06.	
2. The allowed claim(s) is/are <u>1-12</u> .		
3. ☐ Acknowledgment is made of a claim for foreign priority un a) ☐ All _ b) ☐ Some* c) ☐ None of the:		
Certified copies of the priority documents have		
2. Certified copies of the priority documents have	• • • • • • • • • • • • • • • • • • • •	
Copies of the certified copies of the priority do	cuments have been received in this r	national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subminification (PTO-152) which give	itted. Note the attached EXAMINER' es reason(s) why the oath or declarate	S AMENDMENT or NOTICE OF tion is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.	
(a) ☐ including changes required by the Notice of Draftspers		948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or in the O	ffice action of
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the drawin ne header according to 37 CFR 1.121(c	gs in the front (not the back) of
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I 	sit of BIOLOGICAL MATERIAL m FOR THE DEPOSIT OF BIOLOGICA	nust be submitted. Note the AL MATERIAL.
Attachment(s)	5 - Notice of the 19	
1. Notice of References Cited (PTO-892)		atent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	 6. ☐ Interview Summary (Paper No./Mail Date 	
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 3-6-06 	8), 7. 🛛 Examiner's Amendm	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. Examiner's Statement	nt of Reasons for Allowance
of Diological Material	9.	Auber I pur Doll
		RODNEY G. MCDONALD

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REASONS FOR ALLOWANCE

Oath/Declaration

The oath or declaration is defective. A new oath or declaration in compliance with 37 CFR 1.67(a) identifying this application by application number and filing date is required. See MPEP §§ 602.01 and 602.02.

The oath or declaration is defective because:

The inventor Derek M. Stein has improperly dated the oath. Thus failing to properly execute the oath.

The following is an examiner's statement of reasons for allowance:

Claims 1, 5-9 are allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including utilizing a periodic flux of ions having a duty cycle at first and second exposure temperatures as claimed for changing at least one physical dimension by adding material to the structure of the feature.

Claims 2-12 are allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including controlling the ion flux duty cycle as claimed for changing at least one physical dimension of the feature by adding material to the structure of the feature.

The closest prior art of record to U.S. Pat. No. 6,106,677 to Sandhu discloses depositing a layer and then resputtering the layer so that some of the material of the layer is sputtered from the layer and into the aperture (see Figures 2 & 3). There is no

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disclosure of utilizing an ion duty cycle to add material to a feature or utilizing first and second temperature with the duty cycle to add material to a feature.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M- Th with Every other Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Rodney G. McDonald Primary Examiner Art Unit 1753

RM April 13, 2006